



PATENT 2813

Case Docket No. ASMMC.036AUS

Date: May 30, 2003

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s) : Sophie et al.  
Appl. No. : 09/975,466  
Filed : October 9, 2001  
For : IN SITU REDUCTION OF  
COPPER OXIDE PRIOR TO  
SILICON CARBIDE  
DEPOSITION  
Examiner : Kielin  
Group Art Unit : 2813

I hereby certify that this correspondence and all marked attachments are being deposited with the United States Postal Service as first class mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on

May 30, 2003

(Date)

Andrew N. Merickel, Reg. No. 53,317

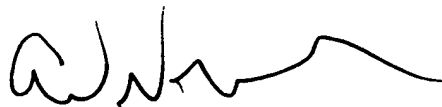
## TRANSMITTAL LETTER

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Dear Sir:

Enclosed for filing in the above-identified application are:

- (X) An Information Disclosure Statement.
- (X) A PTO Form 1449 with one (1) references.
- (X) The Commissioner is hereby authorized to charge any additional fees which may be required, or credit any overpayment, to Account No. 11-1410.
- (X) Return prepaid postcard.

  
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